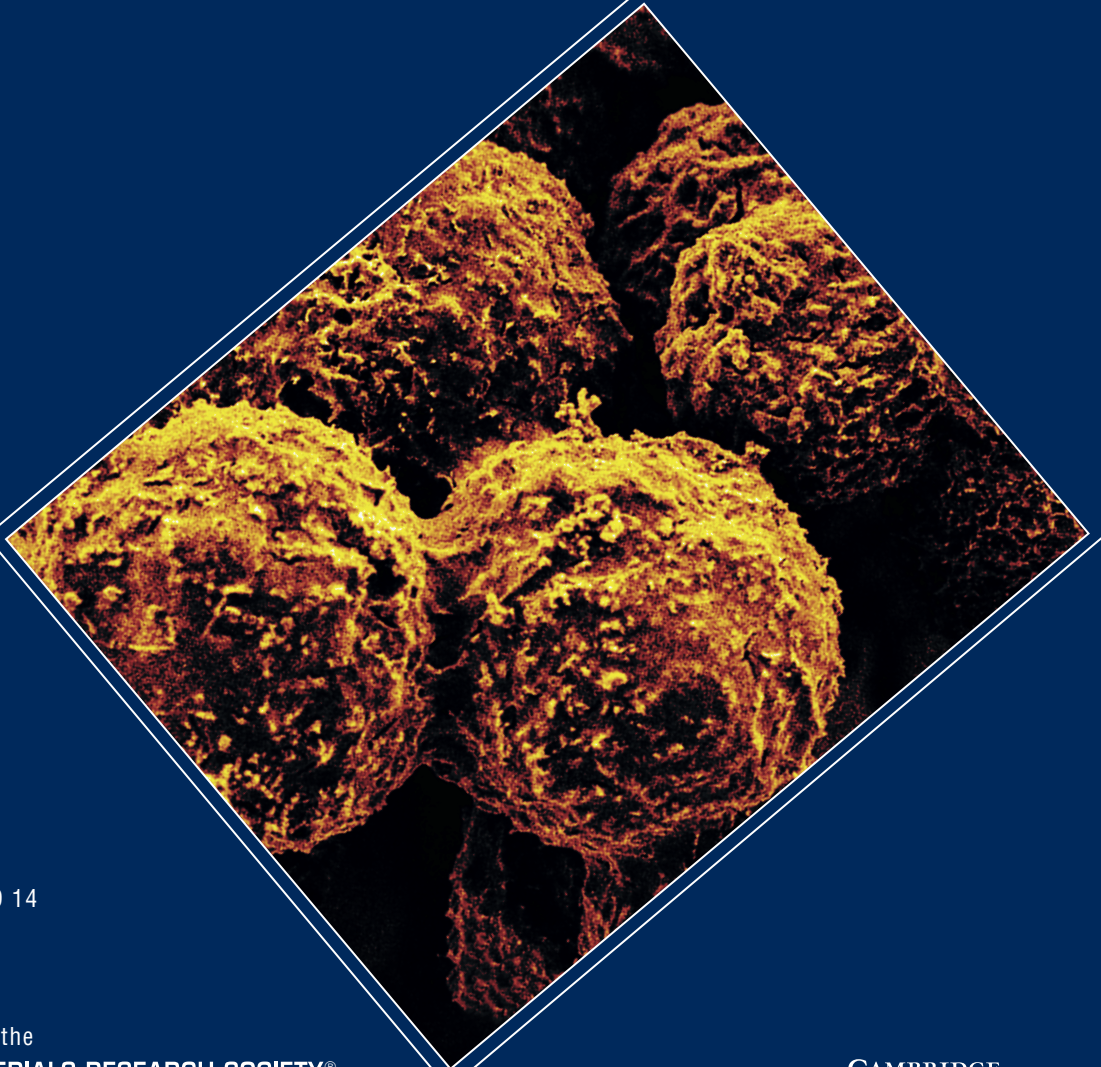




Journal of
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VOLUME 34 • NO 14
JULY 28, 2019

A publication of the

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